Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	4999	bias$3 adj (substrate or wafer or pallet)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/04/05 10:56
L2	71671	(movable or moving or moved or transport$3) near2 (substrate or wafer or pallet)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/04/05 10:57
L3	208002	sputter$3	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/04/05 10:58
L4	17212	(plural or plurality or multiple or multi) adj (target or cathode)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/04/05 11:00
L5	0	1 same 2 same 3 same 4	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/04/05 11:00
L6	29	1 and 2 and 3 and 4	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/04/05 11:00